

Search Notes

Application/Control No.

10/785,598

Examiner

Jacob Y. Choi

Applicant(s)/Patent under
Reexamination

LEE ET AL.

Art Unit

2875

SEARCHED

Class	Subclass	Date	Examiner
362	328, 330, 26, 311, 606, 609	9/27/2005	JC
362	610	9/27/2005	JC
359	64, 65	9/27/2005	JC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Class/Subclass Search	9/27/2005	JC
Text Search Conducted by Examiner	9/27/2005	JC